## Notice of References Cited Application/Control No. 10/805,158 Examiner Art Unit Page 1 of 1 Marcos D. Pizarro-Crespo Applicant(s)/Patent Under Reexamination ONO ET AL. Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2001/0015453	08-2001	Agarwal, Vishnu K.	257/310
	В	US-2004/0108537	06-2004	Tiwari, Sandip	257/314
	O	US-5,372,957	12-1994	Liang et al.	438/302
	D	US-6,451,641	09-2002	Halliyal et al.	438/200
	E	US-6,486,080	11-2002	Chooi et al.	438/785
	F	US-			
	G	US-			
•	Н	US-		·	
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
,	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N				•	
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	Р					
	O					
	R					
	S				·	
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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